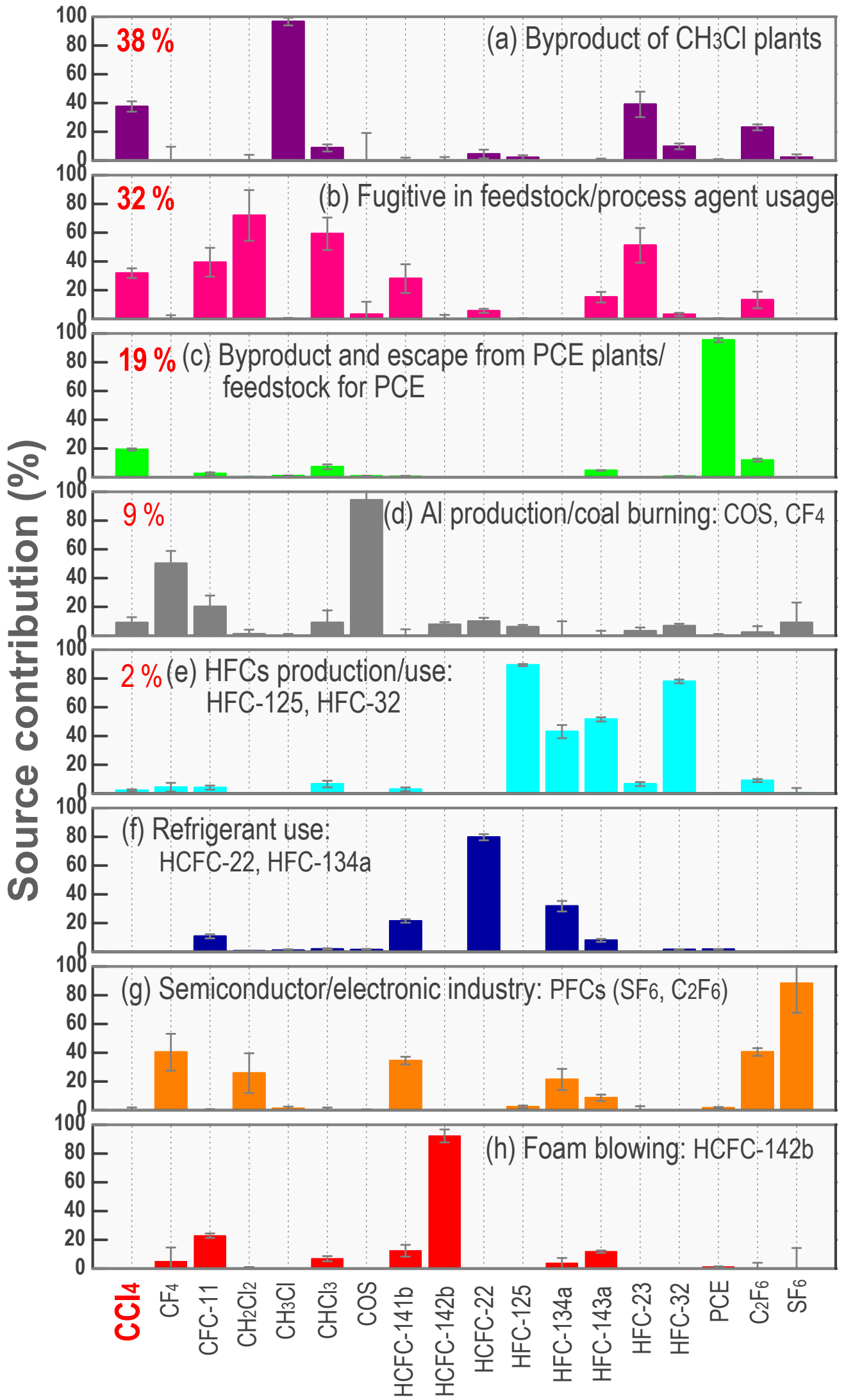
Source contribution (%)
38 %
(a) Byproduct of CH3Cl plants
32 %
(b) Fugitive in feedstock/process agent usage
19 %
(c) Byproduct and escape from PCE plants/ feedstock for PCE
9 %
(d) Al production/coal burning: COS, CF4
2 %
(e) HFCs production/use: HFC-125, HFC-32
(f) Refrigerant use: HCFC-22, HFC-134a
(g) Semiconductor/electronic industry: PFCs (SF6, C2F6)
(h) Foam blowing: HCFC-142b
CCl4
CF4
CFC-11
CH2Cl2
CH3Cl
CHCl3
COS
HCFC-141b
HCFC-142b
HCFC-22
HFC-125
HFC-134a
HFC-143a
HFC-23
HFC-32
PCE
C2F6
SF6